

## **PATENT APPLICATION**

# N THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q80784

Kenji MATSUMOTO

Appln. No.: 10/830,053

Group Art Unit: 2861

Confirmation No.: 8738

Examiner: Hai Chi PHAM

Filed: April 23, 2004

For:

EXPOSURE APPARATUS AND METHOD

# AMENDMENT UNDER 37 C.F.R. § 1.111

# MAIL STOP AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 7, 2007, please amend the aboveidentified application as follows on the accompanying pages.

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